



Proposal Title

Performer Name/Institution (include partner institutions)

Institution Logo

Key Graphic(s) from Technical Volume

Replace this box with an image, diagram, or figure to aid in explaining your work.

Include concept description with bullets/text as necessary.

New Insights/Innovations:

- First key point.
- Additional key points as necessary.

Scientific/Technical Approach Summary:

Program Approach:

- Replace with text bullets and diagrams as necessary.

Assumptions, Risk & Mitigation:

- Describe assumptions of proposed approach, including criteria that will need to be met by partner challenge area projects (or by all for Thrust 2 proposers) and applicability of approach with respect to other deposition methods.
- Address risks of proposed approach, compatibility/requirements, and mitigation strategies.

Compatibility and Limitations:

Proposers to Thrust 1:

- List classes of thin films that should be applicable.
- List compatibility requirements (e.g., optical access, conductive substrate, need for vacuum environment, etc.).
- List required equipment (existing and proposed).

Proposers to Thrust 2:

- Describe compatibility requirements for part and LoCo process.

Budget:

\$